

Application/Control No.	Applicant(s)/Patent under Reexamination
10/778,020	TSUCHIYA, HITOSHI
Examiner	Art Unit
(Nancy) Thanh-Nhan P. Nguyen	2871

SEARCHED						
Class	Subclass	Date	Examiner			
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
UPDATE EAST search see printout. PLUS search see printout.	10/12/2005	TN		
349/113-114.ccls. (text search only) see printout.	10/12/2005	TN		